

Application/Control No.	Applicant(s)/Patent under Reexamination
10/786,187	CHEN ET AL
Examiner	Art Unit

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2822

	SEARCHED		
Class	Subclass	Date	Examiner
438	710	4/29/2005	CN
438	719	4/29/2005	CN
438	720	4/29/2005	CN
438	724	4/29/2005	CN
438	401	4/29/2005	CN
438	975	4/29/2005	CN

	INTERFERENCE SEARCHED				
	Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST Search US PGPUB USPAT EPO JPO	4/29/2005	CN
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